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PATENT
930086-2038**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Heon Jin CHOI, Jae Chul PYUN

Serial No. : Not Yet Assigned

For : NANOWIRE ASSISTED LASER
DESORPTION/IONIZATION MASS SPECTROMETRIC
ANALYSIS

Filed :

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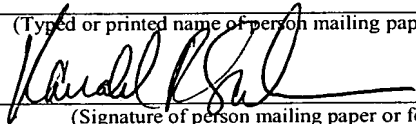
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PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Preliminary to the examination of the above referenced patent application,

Applicants respectfully request that the application be amended as follows: